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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/621,252	07/16/2003	Kuo-Feng Chen	67,200-569A	1265	
7590 04/27/2004			EXAMINER		
Randy W. Tung Tung & Associates			STINSON, F	STINSON, FRANKIE L	
Suite 120			ART UNIT	PAPER NUMBER	
838 W. Long La Bloomfield Hills			1746		
·		DATE MAILED: 04/27/2004			

Please find below and/or attached an Office communication concerning this application or proceeding.

	Application No.	Applicant(s)
055	10/621,252	KUO-FENG ET AL.
Office Action Summary	Examiner	Art Unit
<u> </u>	FRANKIE L. STINSON	1746
The MAILING DATE of this comm Period for Reply	unication appears on the cover sheet w	rith the correspondence address
A SHORTENED STATUTORY PERIOD THE MAILING DATE OF THIS COMMU - Extensions of time may be available under the provisis after SIX (6) MONTHS from the mailing date of this co - If the period for reply specified above is less than thirty - If NO period for reply is specified above, the maximum - Failure to reply within the set or extended period for re - Any reply received by the Office later than three month earned patent term adjustment. See 37 CFR 1.704(b)	INICATION. ons of 37 CFR 1.136(a). In no event, however, may a mmunication. y (30) days, a reply within the statutory minimum of thin on statutory period will apply and will expire SIX (6) MCN ply will, by statute, cause the application to become a one of this communication, and the control of the mailing date of this communication.	reply be timely filed ty (30) days will be considered timely. THS from the mailing date of this communication.
Status		
1) Responsive to communication(s) f	filed on	
2a)☐ This action is FINAL .	2b)⊠ This action is non-final.	
3) Since this application is in condition	on for allowance except for formal matt	ters prosecution as to the morite is
closed in accordance with the prac-	ctice under Ex parte Quayle, 1935 C.D). 11, 453 O.G. 213
Disposition of Claims		
4)⊠ Claim(s) <u>21-26</u> is/are pending in the	20 application	
4a) Of the above claim(s) is.		
5) Claim(s) is/are allowed.	are willidrawn from consideration.	
6)⊠ Claim(s) <u>21-26</u> is/are rejected.		
7) Claim(s) is/are objected to.		
	data a sauto de la companya della companya della companya de la companya della co	
8) Claim(s) are subject to restr	requirement.	
Application Papers		
9)☐ The specification is objected to by t	he Examiner.	
10) The drawing(s) filed on is/ard	e: a)□ accepted or b)□ objected to l	by the Examiner.
	ection to the drawing(s) be held in abeyan	
	ng the correction is required if the drawing(
11)☐ The oath or declaration is objected	to by the Examiner. Note the attached	Office Action or form PTO-152
Priority under 35 U.S.C. § 119		
_		•
12) Acknowledgment is made of a clain a) All b) Some * c) None of:	for foreign phonity under 35 U.S.C. §	119(a)-(d) or (f).
	u do ouer ente le constitue de la constitue de	
	y documents have been received.	
3. Copies of the certified copies	y documents have been received in Ap	oplication No
opplies of the certified copies	of the priority documents have been	received in this National Stage
	onal Bureau (PCT Rule 17.2(a)).	
* See the attached detailed Office action	on for a list of the certified copies not r	eceived.
ttachment(s)		
Notice of References Cited (PTO-892)	4) Interview Su	ımmary (PTO-413)
) Notice of Draftsperson's Patent Drawing Review (I	PTO-948) Paper No(s)	/Mail Date
) Information Disclosure Statement(s) (PTO-1449 of Paper No(s)/Mail Date	r PTO/SB/08) 5) ☐ Notice of Inf 6) ☐ Other:	ormal Patent Application (PTO-152)
	O) Caler.	<u>-</u>
Patent and Trademark Office OL-326 (Rev. 1-04)	Office Action Summary	Part of Paper No /Mail Do

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- 1. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
 - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 2. Claims 21 and 22 are rejected under 35 U.S.C. 103(a) as being unpatentable over either Germany'272, Abe et al., or Mertens et al. in view of Czaja et al. Re claim 21, Germany'272, Abe and Mertens are cited disclosing an apparatus comprising: a wafer jig (6 in Germany'272, unnumbered in Abe, see fig. 13 and 101 in Mertens, see fig 10) constructed and arranged to carry a semiconductor wafer therein, wherein the wafer jig includes an opening therein for exposing a top surface of the semiconductor wafer; a wetting solution supply tank (136 in Czaja, not shown in Abe and Mertens) and a spray module (14 in Germany'272, 710, 720 in Abe and not shown in Mertens, see col. 14, lines 9 in Mertens) that differs from the claim only in the recitation of the pump. The patent to Czaja is cited disclosing in apparatus for processing wafer, a jig and a pump for pumping fluid from a supply tank and to the article being treated. It therefore would have been obvious to one having ordinary skill in the art to modify the apparatus of either Germany'272, Abe or Mertens, to include a pump as taught by Czaja, for the purpose of positively moving the fluid and since although not disclose, the same must obvious be provide for fluid movement. Re claim 21, Germany'272, Abe and Mertens disclose the relative movement as claimed.

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3. Claim 23 is rejected under 35 U.S.C. 103(a) as being unpatentable over either Germany'272, Abe et al. or Mertens et al. in view of Czaja et al. as applied to claim 21 above, and further in view of either Kobayashi et al. or Japan'430.

Claim 23 defines over the applied prior art only in the recitation of the jig being oscillated in the vertical direction. Kobayashi and Japan'430 are both cited disclosing in an apparatus for treating semiconductor wafers, means (13 in Kobayashi and 32 in Japan'430) for oscillating a jig vertically. It therefore would have been obvious to one having ordinary skill in the art to modify the device of either Germany'272, Abe or Mertens, to have the jig oscillated vertically as taught by either Kobayashi or Japan'430, for the purpose of enhancing the cleaning process.

4. Claims 24-26 are rejected under 35 U.S.C. 103(a) as being unpatentable over the applied prior art as applied to claim 21 above, and further in view of either Kanno (U. S. Pat. No. 5,934,566) or Fishkin et al.

Claim 24 defines over the applied prior art only in the recitation of the spray module being constructed and arranged to spray wetting solution particles. Kanno'566 and Fishkin are both cited disclosing in a wafer cleaning apparatus, the arrangement of providing a spray module constructed and arranged to spray wetting solution particles. It therefore would have been obvious to one having ordinary skill in the art to modify the spraying module of either Germany'272, Abe or Mertens, to spray wetting solution particles as taught by either Kanno'566 or Fishkin, for the purpose of enhancing the contaminate removal process. Re claim 25, Kanno'566 disclose the diameter as claimed. Re claim 26, to have the nozzle arranged in a set of three is deemed to be an

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obvious matter of design in that the same is consider a substitution of equivalents in view of the modules as taught by the applied prior art (see MPEP 2144.06).

- 5. The prior art made of record and not relied upon is considered pertinent to applicant's disclosure. In Segawa, Bok et al., Japan'120, Kosic, Yoshizawa, Japan'999, Foederl et al., Ondera, Bankes et al., Kinoshita et al., Japan'268, Japan'629, Wang et al., Oya et al., Kanno'567, Japan'267, Stanasolovich et al., Japan'738, Kanno'380 and Kanno'718, note the wafer treating means.
- 6. Any inquiry concerning this communication or earlier communications from the examiner should be directed to FRANKIE L. STINSON whose telephone number is (571) 272-1308. The examiner can normally be reached M-F from 5:30 a.m. to 2:00 p.m. and some Saturdays from 5:30 a.m. to 11:30 a.m.

The fax phone number for the organization where this application or proceeding is assigned is (703) 872-9306.

Any inquiry of a general nature or relating to the status of this application should be directed to TECHNOLOGY CENTER 1700 (571) 272-1700.

Any inquiry for missing parts of this Office Action (copies of references, pages, forms etc.), contact the TEAM LEADER Ms. Nicol Scott (571) 272-1045.

fls

FRANKIE L. STINSON Primary Examiner Art Unit 1746